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FACSIMILE COVER SHEET

To Examiner: HO, TU TU V	Total Pages Sent: 2
Technology Center 2800	(including cover sheet)
Facsimile Number: (703) 872-9306	Transmission Date: March 1, 2005

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

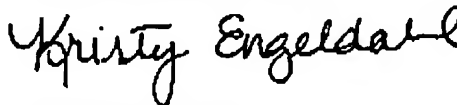
Applicant: Bao, *et al.* Docket No.: TSM03-0927
Serial No.: 10/800,510 Art Unit: 2818
Date Filed: March 15, 2004
TITLE: A Semiconductor Device Having A Second Level Of Metallization Formed Over
A First Level With Minimal Damage To The First Level And Method

CERTIFICATION OF FACSIMILE TRANSMISSION

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Certification of Facsimile Transmission (1 page)
Election (1 page)

Respectfully submitted,



Kristy Engeldahl
Legal Assistant

Confirmation Respectfully Requested

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Docket No.: TSM03-0927

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Examiner: HO, TU TU V

For: A Semiconductor Device Having A Second Level Of Metallization Formed Over A
First Level With Minimal Damage To The First Level And Method

Mail Stop Amendment
Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

ELECTION

Dear Sir:

In response to the restriction requirement set forth in the Office Action mailed on
February 1, 2005, Applicant hereby elects Group II: Claims 24-43 for further prosecution in the
above patent application

Respectfully submitted,

1 March 2005
Date

James C. Kesterson
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